



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application Serial No. .... 10/046,330  
Filing Date ..... 10/25/2001  
Inventor..... W. Yi et al.  
Assignee ..... Honeywell International Inc.  
Group Art Unit..... 2818  
Examiner ..... Phuc T. Dang  
Attorney's Docket No. .... JM32810-CIP  
Title: Physical Vapor Deposition Targets

RESPONSE TO MARCH 5, 2003 OFFICE ACTION

To: Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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AMENDMENTS

In the Specification

None.

In the Claims

None.

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